

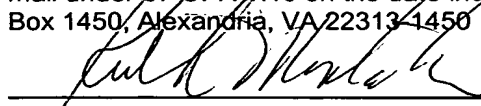


04-30-04

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/ **Ruth Montalvo** Date: **04/29/04**

**Customer No. 026418**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

**Docket No. GK-ZEI-3214 / 500343 20225**

**Applicant(s): Hans-Juergen DOBSCHAL, et al.**

**Application No.: 10/626,130**

**Group:**

**Filed: July 24, 2003**

**Examiner:**

**For: IMAGING SYSTEM FOR A MICROSCOPE BASED ON EXTREME ULTRAVIOLET (EUV) RADIATION**

Commissioner of Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**SUPPLEMENTAL  
INFORMATION DISCLOSURE STATEMENT**

**S I R:**

Supplemental to the Information Disclosure Statement filed on January 15, 2003, enclosed are the following references that were previously omitted:

	Document Number	Date	Name and/or Country	English Translation
<b>AO</b>	<b>102 20 815</b>	<b>11/20/2003</b>	<b>Germany</b>	English Abstract only
<b>AP</b>	<b>102 20 816</b>	<b>11/20/2003</b>	<b>Germany</b>	English Abstract only

This submission is not an admission that the information disclosed in the documents is material to the patentability of the invention disclosed and/or claimed in the above-identified application.

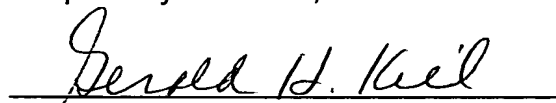
Respectfully submitted,

04/29/04  
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Enclosures:

PTO-1449  
2 documents  
2 English Abstract

  
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